

Cite this: *J. Mater. Chem. A*, 2021, 9, 19659Received 30th March 2021
Accepted 12th May 2021

DOI: 10.1039/d1ta02645c

rsc.li/materials-a

Sliding ferroelectricity in two-dimensional MoA₂N₄ (A = Si or Ge) bilayers: high polarizations and Moiré potentials†

Tingting Zhong,^a Yangyang Ren,^b Zhuhua Zhang,^c Jinhua Gao^b
and Menghao Wu^{id}*^b

According to the model of sliding ferroelectricity we proposed in 2017, a type of vertical polarization switchable *via* interlayer sliding may exist in a series of two-dimensional van der Waals bilayers and multilayers. Such intriguing ferroelectricity has been recently experimentally confirmed in BN and WTe₂ bilayer/multilayer systems. However, they are respectively insulators and metals with weak polarizations. Here, we search for a combination of high-mobility semiconductors and ferroelectricity with relatively high polarizations, and we note that MoSi₂N₄ monolayer has been recently fabricated to centimeter scale based on MoN₂ monolayer (*Science* 2020, 369, 670). We show first-principles evidence of strong interlayer sliding ferroelectricity in high-mobility semiconducting MoA₂N₄ (A = Si or Ge) bilayers and multilayers. They possess tunable bandgaps within the desirable range for nanoelectronics, with the current highest polarizations in sliding ferroelectrics known to date due to strong interlayer van der Waals interactions. Such a successful combination of these properties may render the long-sought and efficient computing-in-memory possible. Their high polarizations induce strong Moiré potential and unique band alignments for exciton trapping in twisted MoA₂N₄ bilayer. The varying charge distribution of different stacking in MoN₂/MoSi₂N₄ hetero-bilayer also gives rise to a high alternating voltage when used as a nanogenerator, suggesting promising potential for energy harvesting.

Introduction

It is known that ferroelectric materials can be used as non-volatile random access memory (RAM) devices due to their

switchable bi-states, which can represent logical “0” and “1”. Driven by the demand of miniaturization and integration of nanodevices, some recent research has been devoted to the search for ferroelectricity in two-dimensional (2D) materials with atomic thickness and clean van der Waals surface.¹ Within several years, the existence of ferroelectricity in a series of 2D van der Waals materials^{2–11} have been experimentally confirmed, in which the ferroelectricity induced by interlayer sliding plays an important role. This mechanism¹² is not available in traditional ferroelectrics but can be applied to many two-dimensional materials: in many two-dimensional van der Waals bilayers, the upper and lower layers are not equivalent, giving rise to a net interlayer charge transfer, and the induced vertical polarization can be switched *via* interlayer sliding. This unique sliding ferroelectricity can widely exist in many van der Waals bilayers, multilayers and even bulk structures. The interlayer sliding barrier is much lower compared with traditional ferroelectrics, which may greatly save the required energy for ferroelectric switching.¹³

Currently, this type of interlayer sliding ferroelectricity has been experimentally confirmed in BN^{14,15} and WTe₂ (ref. 16–19) bilayer/multilayer systems. However, they are respectively insulators and metals with weak polarizations. A successful combination of ferroelectricity and high-performance semiconductors is long-sought but remains elusive for conventional ferroelectrics, hindering their potential applications in nanoelectronics. Here, we search for ferroelectric high-mobility semiconductors with high polarizations. We note that a new member of 2D material family, MoSi₂N₄ monolayer, has been successfully synthesized in a recent experiment,²⁰ which can be viewed as a MoN₂ monolayer sandwiched by two Si–N layers. It has been shown to possess a moderate semiconducting bandgap, excellent stability in air and high hole mobility (~1200 cm² V⁻¹ s⁻¹).²⁰ Subsequent calculations^{21,22} have further revealed some other members in 2D layered MA₂Z₄ (M = Mo, W and Ti, early transition metal; A = Si or Ge; Z = N, P or As) family, which are structurally flexible due to vdW stacking. In this paper, we will show by first-principles calculations that

^aDepartment of Physics, Zhejiang Sci-Tech University, Hangzhou, Zhejiang 310018, China

^bSchool of Physics, Huazhong University of Science and Technology, Wuhan, Hubei 430074, China. E-mail: wmh1987@hust.edu.cn

^cState Key Laboratory of Mechanics and Control of Mechanical Structures, Nanjing University of Aeronautics and Astronautics, Nanjing, Jiangsu 210016, China

† Electronic supplementary information (ESI) available. See DOI: 10.1039/d1ta02645c

bilayer MoSi_2N_4 and MoGe_2N_4 are excellent candidates for achieving high interlayer sliding ferroelectricity in high-performance semiconductors.

Results and discussion

In a very recent theoretical study,²¹ five different stacking configurations of MoSi_2N_4 bilayer have been compared. The ground state turns out to be in the AB and AC stacking orders which are identical. Now we investigate the existence of interlayer sliding ferroelectricity for AB stacking (staggered) MoSi_2N_4 bilayer, and the corresponding bi-stable states are displayed in Fig. 1(a). For state I, at the interlayer interface composed of two Si–N layers, the N atoms of the upper layer are right over the Si atoms in the down layer, while the N atoms of the down layer are below the hexagon center (also the Mo atoms) of the upper layer. Such interlayer inequivalence gives rise to a net charge transfer and a vertical polarization, which can be switched *via* interlayer translation to the state II along either of the three directions marked by the green arrows, moving the Si and N atoms of the upper layer respectively right over the N atoms and Mo atoms in the down layer (see the red dotted lines). The areal density of interlayer charge transfer is estimated to be around $1.31 \mu\text{C cm}^{-2}$, making the upper/down layer respectively p/n doped, which can be revealed by the interlayer differential charge density in Fig. 1(a).

It is the similar case for AB stacking MoGe_2N_4 bilayer. The calculated vertical polarizations are 3.36 pC m^{-1} and 3.05 pC m^{-1} for MoSi_2N_4 and MoGe_2N_4 , and 2.49 pC m^{-1} and 3.44 pC m^{-1} for CrSi_2N_4 and WSi_2N_4 , respectively. They are much higher compared with bilayer WTe_2 (predicted to be ~ 0.37 (ref. 17) and

experimentally measured to be $\sim 0.23 \text{ pC m}^{-1}$ (ref. 18)) and BN ($\sim 2 \text{ pC m}^{-1}$ for both predictions¹² and experimental measurements¹⁴). It may be attributed to the stronger interlayer interaction, noting that its interlayer distance of 2.81 \AA (the vertical distance between the N atoms of the upper and down layers at the van der Waals interface) is much smaller compared with bilayer graphene or BN ($3.10\text{--}3.40 \text{ \AA}$).¹² The nudge-elastic-band²³ (NEB) method is used to estimate the energy barrier of slippage-induced polarization switching, which turns out to be respectively 20.20 and 33.23 meV per unit cell for MoSi_2N_4 and MoGe_2N_4 bilayer, as shown by the pathways in Fig. 1(b). Those values can also be obtained in the dependence of energy on interlayer displacement along the x direction calculated in Fig. S1,[†] revealing typical double-well potentials for ferroelectrics.

The band structures of bilayer MoSi_2N_4 and MoGe_2N_4 in Fig. 2(a) are computed by using the Heyd–Scuseria–Ernzerhof (HSE) hybrid functional,²⁴ revealing an indirect band gap of 2.10 eV for MoSi_2N_4 and 0.98 eV for MoGe_2N_4 , within the desirable ranges for transistors. Meanwhile the electron mobility can reach $7990 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$ according to our calculations in Table S1.[†] Such combination of non-volatile memories with high-mobility semiconductor transistors may enable computing-in-memory architecture where logic and arithmetic operations are performed in memory, which can greatly reduce energy cost associated with data transfer.²⁵ The vertical polarization due to interlayer inequivalence also gives rise to the interlayer difference of distribution in band structures, splitting the bands of two layers by around $0.2\text{--}0.3 \text{ eV}$ that should be degenerate in energy without such polarization. As shown in Fig. 2(b), the valence band maximum (VBM) is distributed in the

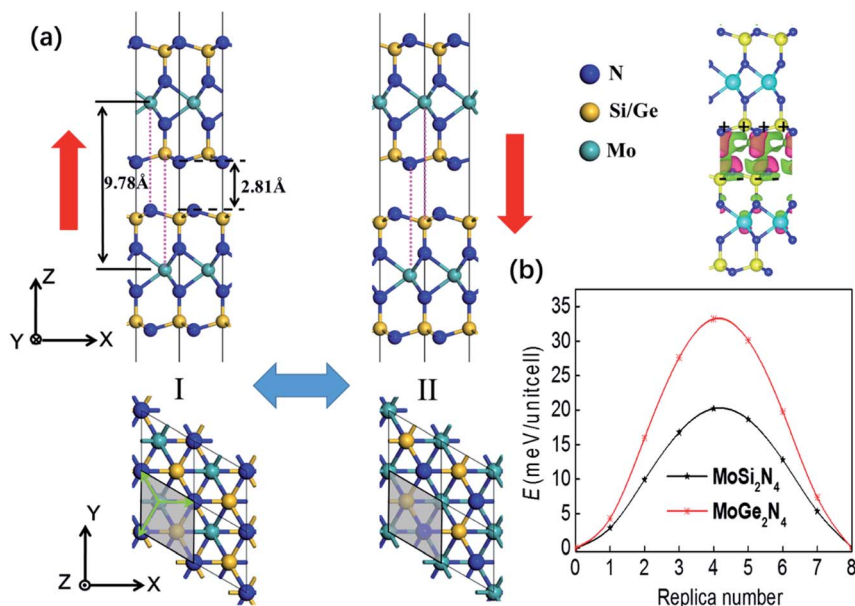


Fig. 1 (a) Geometric structures of bilayer MoSi_2N_4 and MoGe_2N_4 . I and II represent two equivalent states, where the polarization directions are marked by red arrows, the green arrow denotes the direction and distance from state I to state II upon interlayer sliding. For the interlayer differential charge density, green and red isosurfaces indicate electron depletion and accumulation after layer stacking, respectively. (b) The ferroelectric switching pathways of bilayer MoSi_2N_4 and MoGe_2N_4 .

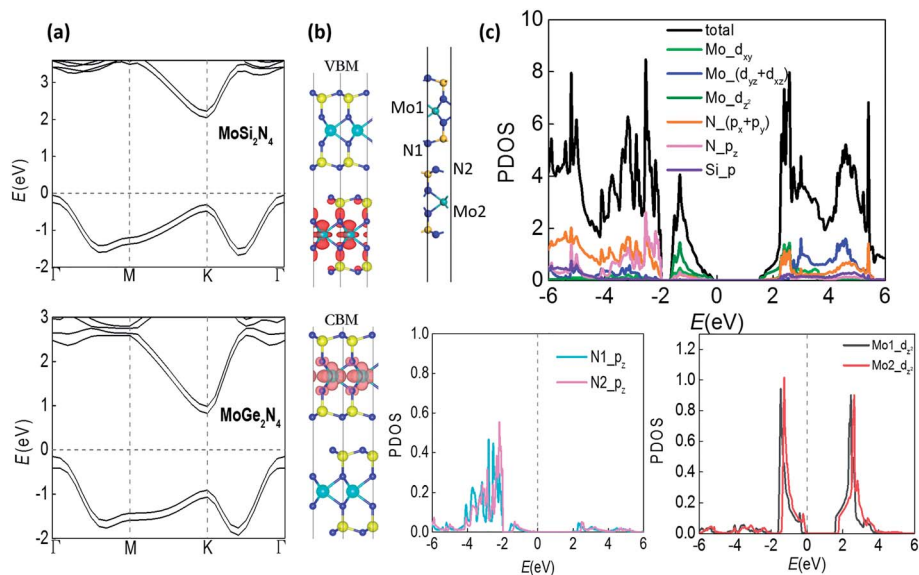


Fig. 2 (a) Band structures of bilayer MoSi₂N₄ and MoGe₂N₄. (b) Distributions of valence band maximum (VBM) and conduction band minimum (CBM) bands, and (c) PDOS analysis for bilayer MoSi₂N₄.

down layer while the conduction band minimum (CBM) is distributed in the upper layer (majorly around Mo atoms in the center). The partial projected density of states (PDOS) in Fig. 2(c) reveals that the bands closest to the Fermi level are mainly distributed by the d_{z²} orbital of Mo atoms and the p_z orbital of N atoms, where the splitting of the PDOS distributed by the two layers (see the splitting between N1 and N2, Mo1 and Mo2) is clearly displayed.

The distribution of the VBM and the CBM in Fig. 2(b) is distinct from most bilayer structures with considerable interlayer hybridizations. Taking the band structure of bilayer MoS₂ in Fig. 3(a) as an example, for the non-polar AA' stacking phase, VBM and CBM are distributed at both layers, indicating

interlayer hybridizations. It is the similar case for the VBM of the polar AB stacking phase, while its CBM is mainly distributed at the down layer due to its weak vertical polarization (predicted to be 0.97 pC m⁻¹),¹² where the band splitting due to its polarization is only 0.049 eV. In comparison, the large splitting of bands (0.2–0.3 eV in Fig. 2(a)) in MoSi₂N₄ bilayer is induced by the vertical polarization while the interlayer hybridization is trivial according to the distribution of the VBM and the CBM in Fig. 2(b). For 2D semiconducting bilayer with a small twist angle, the internal stacking translation $\mathbf{u}(\mathbf{r})$ varying gently with position \mathbf{r} can control the local bandgap $E_g(\mathbf{u}(\mathbf{r}))$.²⁶ Its Moiré potential was mainly induced by interlayer coupling and estimated to be in the order of tens of meV's in hetero-bilayers like

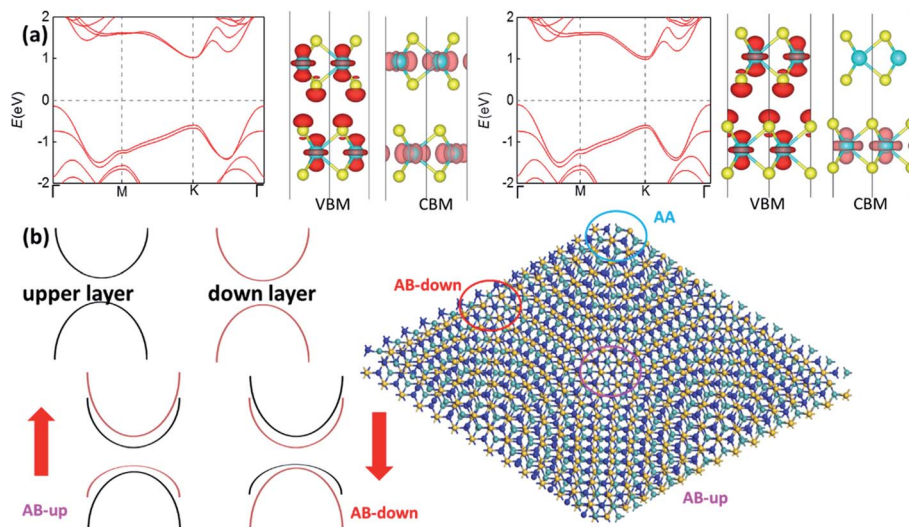


Fig. 3 (a) Band structures of AA' (left) and AB (right) stacking MoS₂ bilayer, and their distributions of VBM and CBM bands. (b) Band alignments of different stacking regions in the Moiré superlattice of twisted MoSi₂N₄ bilayer.

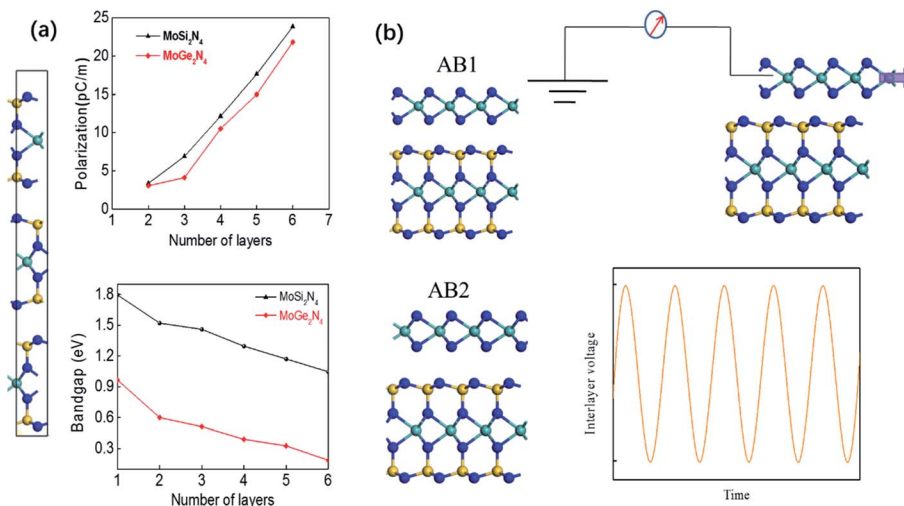


Fig. 4 (a) The dependences of polarizations and bandgaps of ABC stacking MoSi₂N₄ and MoGe₂N₄ thin-layers on the thickness. (b) Different stacking configurations of MoN₂/MoSi₂N₄ hetero-bilayer with distinct interlayer potentials, which can be utilized as nanogenerators.

MoSe₂/WS₂, MoSe₂/MoS₂ and MoTe₂/MoSe₂.²⁷ For twisted MoSi₂N₄ bilayer, however, the origin of Moiré potential will be the vertical polarization that induces the large band splitting instead of interlayer hybridization. The band alignments of different stacking regions are displayed in Fig. 3(b), indicating a quantum dot array with type-II heterojunctions (both in-plane and out-of-plane) that can greatly facilitate exciton trapping.

The ferroelectric phases for MoSi₂N₄ and MoGe₂N₄ multilayers with a higher thickness will be ABC stacking. For ABC-stacked MoSi₂N₄ and MoGe₂N₄ multilayers, Fig. 4(a) shows the increasing trend in polarizations and declining trend in bandgaps with increasing number of layers. Compared with bilayer MoSi₂N₄, the areal polarization is almost enhanced by 8 times while the bandgap decreases by almost half for six-layer MoSi₂N₄. We also note that MoSi₂N₄ monolayer was fabricated based on metallic MoN₂ monolayer, which can also be used as a van der Waals electrical contact.²⁸ It is noteworthy that the lattice mismatch between MoN₂ and MoSi₂N₄ is similar compared with the mismatch between graphene and BN monolayer (~2%), while the commensurate phase of graphene on BN with perfectly matching lattice constants has already been experimentally confirmed.^{29,30} Similar commensurate phase for MoN₂/MoSi₂N₄ heterobilayer is likely to be formed, as shown in Fig. 4(b), where the charge on metallic MoN₂ monolayer will depend on the stacking configurations with distinct polarizations. To our Bader charge analysis, the difference of the charge on the MoN₂ monolayer between AB1 and AB2 stacking configurations will be as high as 0.0413e per unitcell. If the metallic MoN₂ monolayer is dragged along an in-plane direction, the interlayer voltage will oscillate and an alternating current output signal will be generated, which can be used as a nanogenerator. By a coarse estimation using the formula $U = \frac{q \times d}{\epsilon \times S}$, the alternating voltage will be around 1.6 V, almost 8 times higher compared with the previous design of the nanogenerator based on C/BN hetero-bilayer,¹² which can

greatly facilitate driving the flow of electrons and harvest energies.^{31–33}

Conclusion

In summary, through first-principles calculations we show the existence of strong interlayer sliding ferroelectricity in semi-conducting MoA₂N₄ (A = Si or Ge) bilayers and multilayers, which may enable efficient computing-in-memory. They possess the current highest vertical polarizations in sliding ferroelectrics due to strong interlayer van der Waals interactions, while giving rise to intriguing band alignments with negligible interlayer hybridizations. The twisted MoA₂N₄ bilayer with strong Moiré potential can be deemed as a quantum dot array with both in-plane and out-of-plane type-II heterojunctions that can greatly facilitate exciton trapping. In addition, MoN₂/MoSi₂N₄ hetero-bilayer can be utilized as an efficient nanogenerator, suggesting promising potentials for energy harvesting.

Methods

Our calculations were performed based on density functional theory (DFT) methods implemented in the Vienna *Ab initio* Simulation Package (VASP 5.4.4) code.^{34,35} The generalized gradient approximation (GGA) in the Perdew–Burke–Ernzerhof (PBE)³⁶ exchange–correlation functional and the projector augmented wave (PAW)³⁷ formalism were adopted. The kinetic energy cutoff was set at 500 eV. For the geometry optimization, PBE-D2 method of Grimme was used to take vdW interaction into account,³⁸ and the Brillouin zone was sampled by a Γ -centered $9 \times 9 \times 1$ k points using the Monkhorst–Pack scheme.³⁹ All systems were fully relaxed, the convergence threshold for self-consistent-field iteration was set to be 10^{-6} eV and the atomic positions were fully optimized until the forces on all atoms are less than $0.01 \text{ eV } \text{Å}^{-1}$. A vacuum space of 20 Å

was set in the vertical direction. The Berry phase method was employed to evaluate the polarizations of the thin film MoSi_2N_4 and MoGe_2N_4 .⁴⁰

Conflicts of interest

There are no conflicts to declare.

Acknowledgements

The work was supported by the National Natural Science Foundation of China (No. 21573084). We thank Prof. Wei Ji for helpful discussions.

Notes and references

- M. Wu and P. Jena, *Wiley Interdiscip. Rev.: Comput. Mol. Sci.*, 2018, **8**, e1365.
- M. Wu and X. C. Zeng, *Nano Lett.*, 2016, **16**, 3236–3241.
- Y. Bao, P. Song, Y. Liu, Z. Chen, M. Zhu, I. Abdelwahab, J. Su, W. Fu, X. Chi, W. Yu, W. Liu, X. Zhao, Q. H. Xu, M. Yang and K. P. Loh, *Nano Lett.*, 2019, **19**, 5109–5117.
- K. Chang, J. Liu, H. Lin, N. Wang, K. Zhao, A. Zhang, F. Jin, Y. Zhong, X. Hu, W. Duan, Q. Zhang, L. Fu, Q.-K. Xue, X. Chen and S.-H. Ji, *Science*, 2016, **353**, 274.
- P. Sutter, H. P. Komsa, H. Lu, A. Gruverman and E. Sutter, *Nano Today*, 2021, **37**, 101082.
- N. Higashitarumizu, H. Kawamoto, C.-J. Lee, B.-H. Lin, F.-H. Chu, I. Yonemori, T. Nishimura, K. Wakabayashi, W.-H. Chang and K. Nagashio, *Nat. Commun.*, 2020, **11**, 2428.
- C. Zheng, L. Yu, L. Zhu, J. L. Collins, D. Kim, Y. Lou, C. Xu, M. Li, Z. Wei, Y. Zhang, M. T. Edmonds, S. Li, J. Seidel, Y. Zhu, J. Z. Liu, W.-X. Tang and M. S. Fuhrer, *Sci. Adv.*, 2018, **4**, eaar7720.
- W. Ding, J. Zhu, Z. Wang, Y. Gao, D. Xiao, Y. Gu, Z. Zhang and W. Zhu, *Nat. Commun.*, 2017, **8**, 14956.
- T. Ghosh, M. Samanta, A. Vasdev, K. Dolui, J. Ghatak, T. Das, G. Sheet and K. Biswas, *Nano Lett.*, 2019, **19**, 5703–5709.
- M. Wu and X. C. Zeng, *Nano Lett.*, 2017, **17**, 6309–6314.
- F. Liu, L. You, K. L. Seyler, X. Li, P. Yu, J. Lin, X. Wang, J. Zhou, H. Wang, H. He, S. T. Pantelides, W. Zhou, P. Sharma, X. Xu, P. M. Ajayan, J. Wang and Z. Liu, *Nat. Commun.*, 2016, **7**, 12357.
- L. Li and M. Wu, *ACS Nano*, 2017, **11**, 6382–6388.
- T. Zhong and M. Wu, *Acta Phys. Sin.*, 2020, **69**, 217707.
- K. Yasuda, X. Wang, K. Watanabe, T. Taniguchi and P. Jarillo-Herrero, 2020, arXiv preprint arXiv:2010.06600.
- M. Vizner Stern, Y. Waschitz, W. Cao, I. Nevo, K. Watanabe, T. Taniguchi, E. Sela, M. Urbakh, O. Hod and M. Ben Shalom, 2020, arXiv e-prints, arXiv:2010.05182.
- P. Sharma, F.-X. Xiang, D.-F. Shao, D. Zhang, E. Y. Tsybal, A. R. Hamilton and J. Seidel, *Sci. Adv.*, 2019, **5**, eaax5080.
- Q. Yang, M. Wu and J. Li, *J. Phys. Chem. Lett.*, 2018, **9**, 7160–7164.
- Z. Fei, W. Zhao, T. A. Palomaki, B. Sun, M. K. Miller, Z. Zhao, J. Yan, X. Xu and D. H. Cobden, *Nature*, 2018, **560**, 336–339.
- J. Xiao, Y. Wang, H. Wang, C. D. Pemmaraju, S. Q. Wang, P. Muscher, E. J. Sie, C. M. Nyby, T. P. Devereaux, X. F. Qian, X. Zhang and A. M. Lindenberg, *Nat. Phys.*, 2020, **16**, 1028.
- Y.-L. Hong, Z. Liu, L. Wang, T. Zhou, W. Ma, C. Xu, S. Feng, L. Chen, M.-L. Chen and D.-M. Sun, *Science*, 2020, **369**, 670–674.
- H. Zhong, W. Xiong, P. Lv, J. Yu and S. Yuan, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2021, **103**, 085124.
- L. Wang, Y. Shi, M. Liu, A. Zhang, Y.-L. Hong, R. Li, Q. Gao, M. Chen, W. Ren, H.-M. Cheng, Y. Li and X.-Q. Chen, *Nat. Commun.*, 2021, **12**, 2361.
- G. Henkelman, B. P. Uberuaga and H. Jónsson, *J. Chem. Phys.*, 2000, **113**, 9901–9904.
- J. Heyd, G. E. Scuseria and M. Ernzerhof, *J. Chem. Phys.*, 2003, **118**, 8207–8215.
- M. Si, A. K. Saha, S. Gao, G. Qiu, J. Qin, Y. Duan, J. Jian, C. Niu, H. Wang, W. Wu, S. K. Gupta and P. D. Ye, *Nat. Electron.*, 2019, **2**, 580–586.
- M. Wu, X. Qian and J. Li, *Nano Lett.*, 2014, **14**, 5350–5357.
- D. A. Ruiz-Tijerina and V. I. Fal'ko, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2019, **99**, 125424.
- L. Cao, G. Zhou, Q. Wang, L. K. Ang and Y. S. Ang, *Appl. Phys. Lett.*, 2021, **118**, 013106.
- C. R. Woods, L. Britnell, A. Eckmann, R. S. Ma, J. C. Lu, H. M. Guo, X. Lin, G. L. Yu, Y. Cao, R. V. Gorbachev, A. V. Kretinin, J. Park, L. A. Ponomarenko, M. I. Katsnelson, Y. N. Gornostyrev, K. Watanabe, T. Taniguchi, C. Casiraghi, H. J. Gao, A. K. Geim and K. S. Novoselov, *Nat. Phys.*, 2014, **10**, 451–456.
- M. Yankowitz, K. Watanabe, T. Taniguchi, P. San-Jose and B. J. LeRoy, *Nat. Commun.*, 2016, **7**, 13168.
- F.-R. Fan, Z.-Q. Tian and Z. Lin Wang, *Nano Energy*, 2012, **1**, 328–334.
- L. Zhang, B. Zhang, J. Chen, L. Jin, W. Deng, J. Tang, H. Zhang, H. Pan, M. Zhu, W. Yang and Z. L. Wang, *Adv. Mater.*, 2016, **28**, 1650–1656.
- W. Yang, J. Chen, G. Zhu, J. Yang, P. Bai, Y. Su, Q. Jing, X. Cao and Z. L. Wang, *ACS Nano*, 2013, **7**, 11317–11324.
- G. Kresse and J. Furthmüller, *Comput. Mater. Sci.*, 1996, **6**, 15–50.
- G. Kresse and J. Furthmüller, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1996, **54**, 11169.
- J. P. Perdew, K. Burke and M. Ernzerhof, *Phys. Rev. Lett.*, 1996, **77**, 3865.
- P. E. Blochl, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1994, **50**, 17953–17979.
- S. Grimme, *J. Comput. Chem.*, 2006, **27**, 1787–1799.
- H. J. Monkhorst and J. D. Pack, *Phys. Rev. B: Solid State*, 1976, **13**, 5188–5192.
- R. D. King-Smith and D. Vanderbilt, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1993, **47**, 1651–1654.